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CONFIRMATION NO. 7302

SERIAL NUMBER 09/942,038	FILING DATE 08/30/2001  RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. 0819-0637	
APPLICANTS  Yoshihiro Mori, Osaka, JAPAN;  Yasutoshi Okuno, Kyoto, JAPAN; Akihiko Tsuzumitani, Osaka, JAPAN;  ** CONTINUING DATA ***** <i>None HD</i>  ** FOREIGN APPLICATIONS ***** JAPAN 2000-265284 09/01/2000 <i>HD</i>  IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/15/2001					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>[Signature]</i> <i>[Initials]</i> Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 9	TOTAL CLAIMS 15	INDEPENDENT CLAIMS 4
ADDRESS 22204 NIXON PEABODY, LLP 401 9TH STREET, NW SUITE 900 WASHINGTON, DC 20004-2128					
TITLE Method for fabricating semiconductor device including annealing an electrode in a reducing atmosphere before capacitor insulating film forming					
FILING FEE  RECEIVED 1242	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		